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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Cem Basceri, et al.

Serial No.: 10/762,847

Filed: 1/22/2004

For: Micromachines for Delivering
Precursors and Gases
for Film Deposition

Group Art Unit: unk

Examiner: unk

Atty. Dkt. No.: 102-0075US3

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria VA, 22313-1450

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Information Disclosure Statement (IDS) be entered and the documents listed on attached Form PTO-1449 be considered by the Examiner and made of record. Copies of the listed documents are attached.

In accordance with 37 C.F.R §§ 1.97(g),(h), this IDS is not to be construed as a representation that a search has been made, and is not to be construed to be an admission that the information cited is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b), or that such information constitutes prior art.

This IDS is being filed before receipt of a first office action on the merits. Accordingly, no fee is believed due pursuant to 37 C.F.R. § 1.97(b). However, should any fees be due, the

PTO is authorized to deduct any necessary fees from Deposit Account No. 501922, referencing matter no. 102-0075US3.

Applicant respectfully requests that the listed documents be considered and made of record in the present case, and that the Examiner initial the appropriate spaces on the Form 1449 to evidence the same

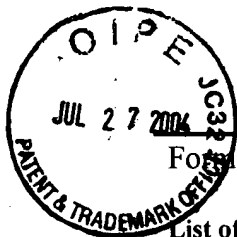
Respectfully submitted,



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7/16/04



Form PTO-1449 (modified)

Atty. Docket No.
102-0075US3Serial No.
10/762,847

List of Patents and Publications for Applicant's

Applicant / Inventor
Micron Technology, Inc., / Cem Basceri et al.

INFORMATION DISCLOSURE STATEMENT

Filing Date:
1/22/2004Group:
unk

(Use several sheets if necessary)

U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.
	A1	6080446	6/27/2000	Tobe et al.	427	255.394	
	A2	6596085	7/22/2003	Schmitt et al.	118	726	2/1/2000
	A3	5380396	1/10/1995	Shikida et al	156	630	
	A4	6705345	3/16/2004	Bifano	137	597	11/8/2000
	A5	6432831	8/13/2002	Dhindsa	438	710	3/23/2001
	A6	6358323	3/19/2002	Schmitt et al.	118	726	6/21/1998
	A7	6302964	10/16/2001	Umotoy	118	715	3/16/2000
	A8	6287980	9/11/2001	Hanazaki et al.	438	726	10/12/1999
	A9	6245192	6/12/2001	Dhindsa et al.	156	345	
	A10	6086677	7/11/2000	Umotoy et al.	118	715	
	A11	6032923	3/7/2000	Biegelsen et al.	251	129.01	
	A12	5953634	9/14/1999	Kajita et al.	438	687	
	A13	5500256	3/19/1996	Watabe	427	579	
	A14	5091207	2/25/1992	Tanaka	427	8	
	A15						

Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Class	Sub Class	Translation Yes/No
	B1	2002-164336	6/7/2002	Japan			yes
	B2						

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation
	C1	

EXAMINER:

DATE CONSIDERED:

EXAMINER: INITIAL IF REFERENCE CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.